Att'y Dkt. No. 003-083 U.S. App. No. 10/660523



E UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gisbert Wolfgang KÄFER

Appl. No.: 10/660523

Filing Date: 12 September 2003

Title: METHOD FOR OPERATING A FLUE GAS

PURIFICATION PLANT

Art Unit: [to be assigned]

Examiner: [to be assigned]

Atty. Docket: 003-083

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Listed on the accompanying Form PTO-1449 are documents that may be considered material to the examination of this application, in compliance with the duty of disclosure requirements of 37 C.F.R. §§ 1.56, 1.97 and 1.98.

Applicants reserve the right to establish the patentability of the claimed invention over any of the information provided herewith, and/or to prove that this information may not be prior art, and/or to prove that this information may not be enabling for the teachings purportedly offered.

This statement should not be construed as a representation that an exhaustive search has been made, or that there does not exist information more material to the examination of the present patent application. The Examiner is specifically requested not to rely solely on the material submitted herewith. It is further understood that the Examiner will review art of record in all 35 U.S.C. § 120 priority documents.

∑1. This Information Disclosure Statement is being filed within three months of the U.S. filing date
 OR before the mailing date of a first Office Action on the merits. No certification or fee is
 required.

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☐ 2.	The Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.					
		a.	Below is a certification under 37 C.F.R. § 1.97(e).			
		b.	Attached is my check no in the amount of \$ in payment of the fee under 37 C.F.R. § 1.17(p).			
		c.	Please charge my Deposit Account No. <u>50-2821</u> in the amount of \$ for the fee under 37 C.F.R. § 1.17(p)			
<u></u> 3.	This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee. Applicant hereby Petitions that the Information Disclosure Statement be considered. Attached is my check please charge my Deposit Account No. 50-2821 in the amount of \$180.00 in payment of the fee under 37 C.F.R. § 1.17(p).					
4	Certifi	cation(s)	under 37 C.F.R. § 1.97(e):			
		a.	I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(1).			
		b.	I hereby certify that no item of information on this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(2).			
□ 5.			ne non-English language document(s) is discussed in the present specification. See the specification of the present application.			
☐ 6 .	The document(s) was/were cited in a corresponding foreign application. A copy of a search report issued in the foreign application is attached. An English language version of the foreign search report is attached for the Examiner's information. M.P.E.P. § 609 (A)(3).					
☐ 7.	A concise explanation of the relevance of the non-English language document(s) is attached hereto or appears below.					

☐ 8.	The Examiner's attention is directed to co-pending U.S. Patent Application No, filed, which is directed to related technical subject matter. The identification of this U.S.				
	Patent Application is not to be construed as a waiver of secrecy as to that application now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited application and the art cited therein during examination.				
□ 9.	Copies of the documents were cited by or submitted to the Office in Application No, filed, which is relied upon for an earlier filing date under 35 U.S.C. § 120. Thus, copies of these documents are not attached. 37 C.F.R. § 1.98(d).				
<u> </u>	Other: .				
	It is respectfully requested that the Examiner initial and return a copy of the enclosed PTO-1449,				
and to	indicate in the official file wrapper of this patent application that the documents have been				
conside	ered.				
	Respectfully submitted,				
	By:				
	Adam J. Cermak				
	Reg. No. 40301				

Date: 5 NOV. 2003

U.S. P.T.O. Customer Number 36844

Law Office of Adam J. Cermak P.O. Box 7518 Alexandria, VA 22307-7518 703.768.0994

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FORM PTO 1449 INFORMATION DISCLOSURE STATEMENT	APPLICANT(S): KÄFER		
INFORMATION DISCLOSURE STATEMENT	FILING DATE: 12 Sept. 2003	Group Art Unit:	

		U.S	S. PATENT DOCUMEN	1TS		
EXAMINER	DOCUMENT	PUB'N	NAME	CLASS	SUB-	FILING DATE
INITIAL	NUMBER	DATE			CLASS	
	5953911	21 Sept. 1999	Guth et al.	60	295	
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INITIAL	NUMBER				CLASS	

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION
						□Yes □ No
			W-1.			□Yes □ No
					*	□Yes □ No
		···				□Yes □ No
						□Yes □ No

OTHER (Including Author, Title, Date, Pertinent Pages, Publisher, etc.)

Czarnecki, L., et al., "SCONOxTM - Ammonia Free NOx Removal Technology FOR GAS TURBINES", Proceedings of 2000 International Joint Power Generation Conference, Miami Beach, FL, 23-26 July 2000, pp. 1-10 (2000, ASME, New York) U.S. Application No. 10/660,521, KÄFER, filed 12 Sept. 2003 U.S. Application No. 10/660,522, KÄFER, filed 12 Sept. 2003

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.